Application/Control No.	Applicant(s)/Patent under Reexamination	
10/588,561	KIM ET AL.	
Examiner	Art Unit	
Qiuwen Mi	1655	

SEARCHED					
Class	Subclass	Date	Examiner		
none	performed				

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
stn, west (USPT, JPAB, EPAB, DWPI)- See Search History Printout	1/17/2008	QM	
inventor search	1/17/2008	QM	
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